

Ultra Precision Manufacturing Conference 2015

Tuesday 12 May 2015

Institute for Manufacturing, Cambridge, Lecture Theatres

Agenda

- 08:45 09:15 Arrival and Registration
- 09:15 09:30 Welcome and Introduction Conference Team
- 09:30 09:50 Introduction to the TRL (Technology Readiness Level) Martin O'Hara, National Strategy Manager EPSRC Centre for Innovative Manufacturing in Ultra Precision
- 09:50 10:10 How to Approach the Next Generation of Optical Instruments Prof. Richard Leach, University of Nottingham
- 10:10 10:30 The Latest Advances in High Precision Laser Micromachining Alan Ferguson, Oxford Lasers
- 10:30 11:00 BREAK
- 11:00 12:20 Ultra Precision PhD Presentations Centre for Innovative Manufacturing and Centre for Doctoral Training in Ultra Precision PhD Students
- 12:20 13:20 Networking Lunch
- 13:20 13:40 Nano Ploughing A Scale Up Nanofabrication Method Dr. Sun Jining, Heriot-Watt University
- 13:40 14:00 Nanoanalysis in the SEM: From Nanolayer Down to Single Atoms Christian Lang, Oxford Instruments
- 14:00 14:20 Nano-Metrology: X-rays, Optical Interferometry, AFM Metrology and Nano Positioning Andrew Yacoot, National Physical Laboratory (NPL)
- 14:20 14:40 AFM Probed-Based Machining Dr. Emmanuel Brousseau, Cardiff University
- 14:40 15:10 BREAK
- 15:10 15:30 Challenges in Geometrical Metrology for Additive Manufacturing Prof. Xiangqian (Jane) Jiang, University of Huddersfield
- 15:30 15:50 Engineering of Surface using Laser-Initiated Liquid-Assisted Colloidal Lithography Dr. Magdalena Ulmeanu, University of Bristol
- 15:50 16:10 Ultra Precision Machining for Integrated Photonic Devices Dr. Lewis G. Carpenter, University of Southampton
- 16:10 16:30 PiMag 6D Levitation in Six Degrees of Freedom Kevin Grimley, PI UK Ltd
- 16:30 16:50 The Marriage of Robots and Zeeko Machines Steps Towards a Versatile, Automated, Manufacturing cell Richard Freeman, Zeeko Ltd
- 16:50 17:00 Closing Remarks Conference Team

ultraprecision.org

Cranfield UNIVERSITY



